Search Notes		

Application No.	Applicant(s)
10/621,488	YAMAGUCHI, HITOSHI
Examiner	Art Unit
Anh D. Mai	2814

	SEARCHED			
Class	Subclass	Date	Examiner	
257	330-331 338;341 342	4/12/2004	A.M	
	,			

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
257	331; 338	4/14/2004	A.M
	342	4/14/2004	A.M

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST (all): * Inventors * CCLS *(power MOS) and source and drain and well and trench	4/12/2004	A.M
IEEE: * trench gate * power MOSFET	4/13/2004	A.M